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10/509898

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q83944

Hiroto OHTAKE, et al.

Appln. No.: 10/509,898

Group Art Unit: Unknown

Confirmation No.: Unknown

Examiner: Unknown

Filed: October 01, 2004

For:

SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD FOR THE SAME

SUBMISSION OF INTERNATIONAL PRELIMINARY EXAMINATION REPORT (IPER)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

For the Examiner's convenience, enclosed herewith is a copy of the English translation of the International Preliminary Examination Report (IPER). It is assumed that copies of the cited references as required by §371(c) will be supplied directly by the International Bureau, but if further copies are needed, the undersigned will undertake to provide them upon request.

Respectfully submitted,

Registration No. 25,665

SUGHRUE MION, PLLC

Telephone: (202) 293-7060

Facsimile: (202) 293-7860

washington office 23373 customer number

Date: March 22, 2005